

FORM PTO-1449 (Rev. 2-32) U.S. Department of Commerce Patent and Trademark Office INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)		Atty. Docket No. 100077	Serial No. IBD 10/689,167
		Applicant: Heinz Busta	
		Filing Date: October 20, 2003	Group: IBD 2822

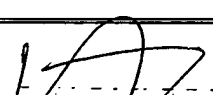
U. S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
MP	5,602,671	2/11/97	Hornbeck	_____	_____	_____
MP	5,694,740	12/9/97	Martin et al.	_____	_____	_____
MP	6,004,830	12/21/99	Potter	_____	_____	_____
MP	6,025,767	2/15/00	Kellam et al.	_____	_____	_____
MP	6,100,477	8/8/00	Randall et al.	_____	_____	_____
MP	6,109,105	8/29/00	Kubena et al.	_____	_____	_____
MP	6,198,438	3/6/01	Herd et al.	_____	_____	_____

FOREIGN PATENT DOCUMENTS

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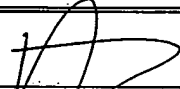
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MP	Zhu, X-Y et al., "Molecular Assemblies on Silicon Surfaces via Si-O Linkages," Langmuir 16, (No. 17 2000), pp. 6766-6772.
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MP	Wilkerson et al., "Flip-Chip Hermetic Packaging of RF MEMS," MEMS Conference, 2001.
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